Electronic Patent Application Fee Transmittal							
Application Number:	10587500						
Filing Date:	27-Jul-2006						
Title of Invention:	Method of manufacturing semiconductor device and apparatus for processing substrate						
First Named Inventor/Applicant Name:	Takaaki Noda						
Filer:	James Albert Oliff/Erin Douglass						
Attorney Docket Number:	128807						
Filed as Large Entity							
U.S. National Stage under 35 USC 371 Filing	Fees						
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)			
Basic Filing:			,				
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
Extension-of-Time:							

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)				
Miscellaneous:								
Submission-Information Disclosure Stmt	1806	1	180	180				
	Tot	180						